

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: HATTORI, Kazuhiro

Group Art Unit: 1765

Serial No.: 09/816,784

Examiner: Lan Vinh

Filed: March 26, 2001

P.T.O. Confirmation No.: 5542

FOR: DRY ETCHING METHOD, MICROFABRICATION PROCESS AND DRY ETCHING

MASK

AMENDMENT TRANSMITTAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

May 6, 2004

Sir:

Transmitted herewith is an Amendment in the above-identified application. The fee has been calculated as shown below:

	CLAIMS AS AMENDED						,
	Claims Remaining After Amendment	Highest Number Previously Paid For		Present Extra	Small Entity	Large Entity	Additional Fee
Total Claims	21	20	=	1	X \$9	X \$18	18.00
Independent Claims	5	4	=	1	X \$43	X \$86	86.00
First Presentation of Multiple Dependent Claims					\$145	290	
•	-4-			TC	TAL FEES EN	CLOSED:	104.00

- <u>XX</u> Enclosed please find our check in the amount of \$104.00 for the additional claims fee in connection with this amendment.
- XX The Commissioner is hereby authorized to charge payment for any additional fees associated with this communication or credit any overpayment to Deposit Account No. <u>01-2340</u>.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP

Susanne M. Hopkins
Attorney for Applicant

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PATENT TRADEMARK OFFICE



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DRY ETCHING METHOD, MICROFABRICATION PROCESS AND DRY For:

ETCHING MASK

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir:

May 6, 2004

In response to the Office Action dated February 12, 2004, please amend the above-identified application as follows: